

**EAST - [10781217.wsp:1]**

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color near filter and color near resist and planarization near layer

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     S5: (530) color near resist and color near filter  
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	U	I	Document ID	Issue Date	Pages	Title	Current OR	Current XRef
1	<input type="checkbox"/>	<input type="checkbox"/>	US 20040248384 A1	20041209	14	Image sensor fabrication method and structure	438/462	
2	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20040248383 A1	20041209	10	Method to reduce excess color filter signal deviation	438/462	
3	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20040234873 A1	20041125	13	Color filter imaging array and method of formation	430/7	
4	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20040126914 A1	20040701	16	Method of forming a thin film transistor and method of forming the thin film transistor on a color filter	438/30	438/163
5	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20040119921 A1	20040624	11	Method of forming a color filter having various thicknesses and a transfective LCD with the color filter	349/114	
6	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20040070039 A1	20040415	18	Solid state image pickup element and method of manufacturing a solid state pickup element	257/428	257/452; 438/48; 438/57
7	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20040023425 A1	20040205	17	METHOD OF FORMING A COLOR FILTER ON A SUBSTRATE HAVING PDEL DRIVING ELEMENTS	438/27	438/609
8	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20040007752 A1	20040115	33	Active matrix substrate having column spacers integral with protective layer and process for fabrication thereof	257/443	
9	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20040002178 A1	20040101	9	Bottom antireflection coating color filter process for fabricating solid state image sensors	438/57	
10	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20030211405 A1	20031113	14	Color filter imaging array and method of formation	430/7	348/65; 348/77; 600/242
11	<input checked="" type="checkbox"/>	<input type="checkbox"/>	US 20030137630 A1	20030724	16	Display element and production method therefor	349/153	

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